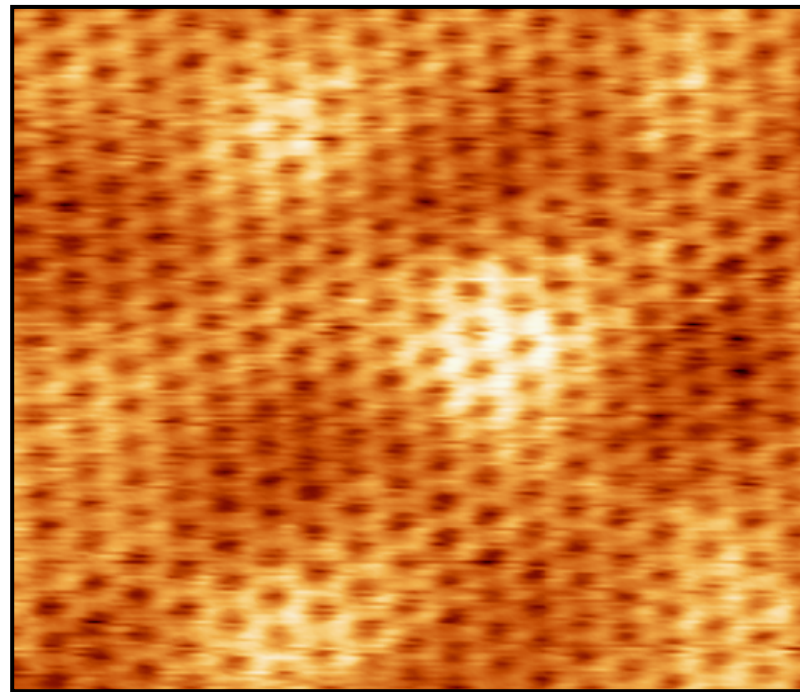
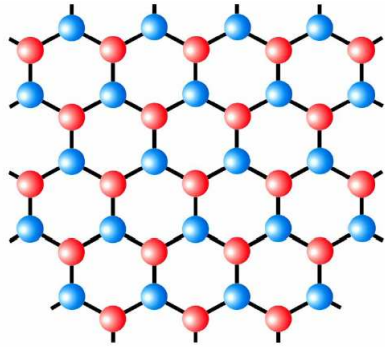


Probing quantum interference effects in epitaxial graphene: STM and magnetotransport studies

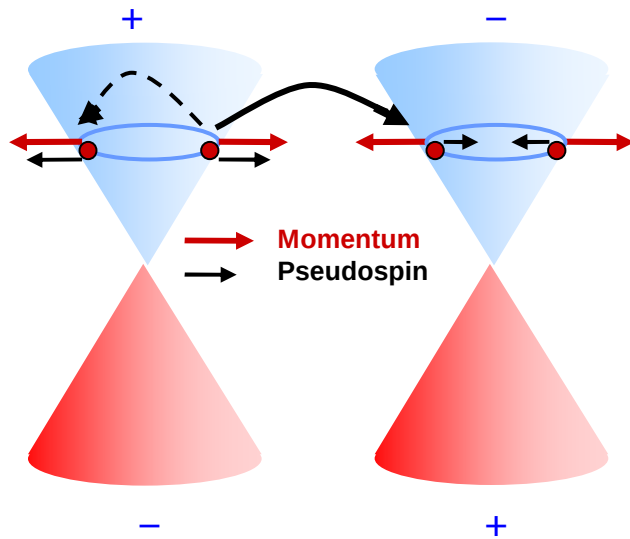


Ather Mahmood, C. Naud, J-Y. Veuillen, P. Mallet,
L.P. Lévy

Quasi particle scattering in graphene

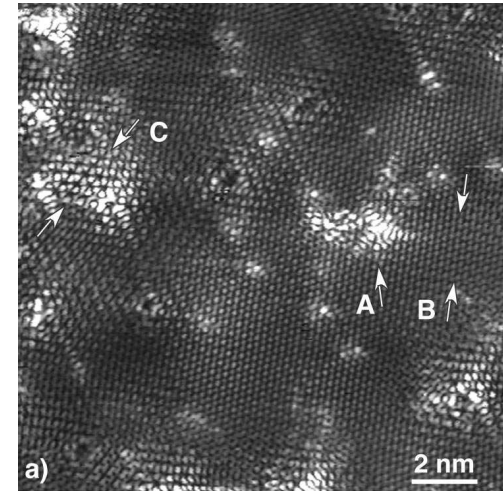


Addl. Quantum numbers:
Pseudospin and Isospin
» intervalley, intra valley scattering

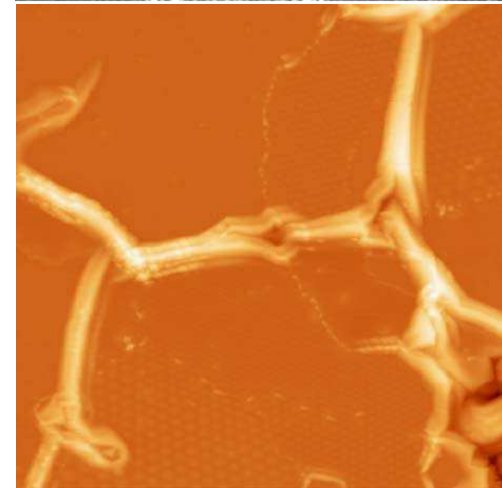


Defects contribute to scattering

Atomically sharp defects



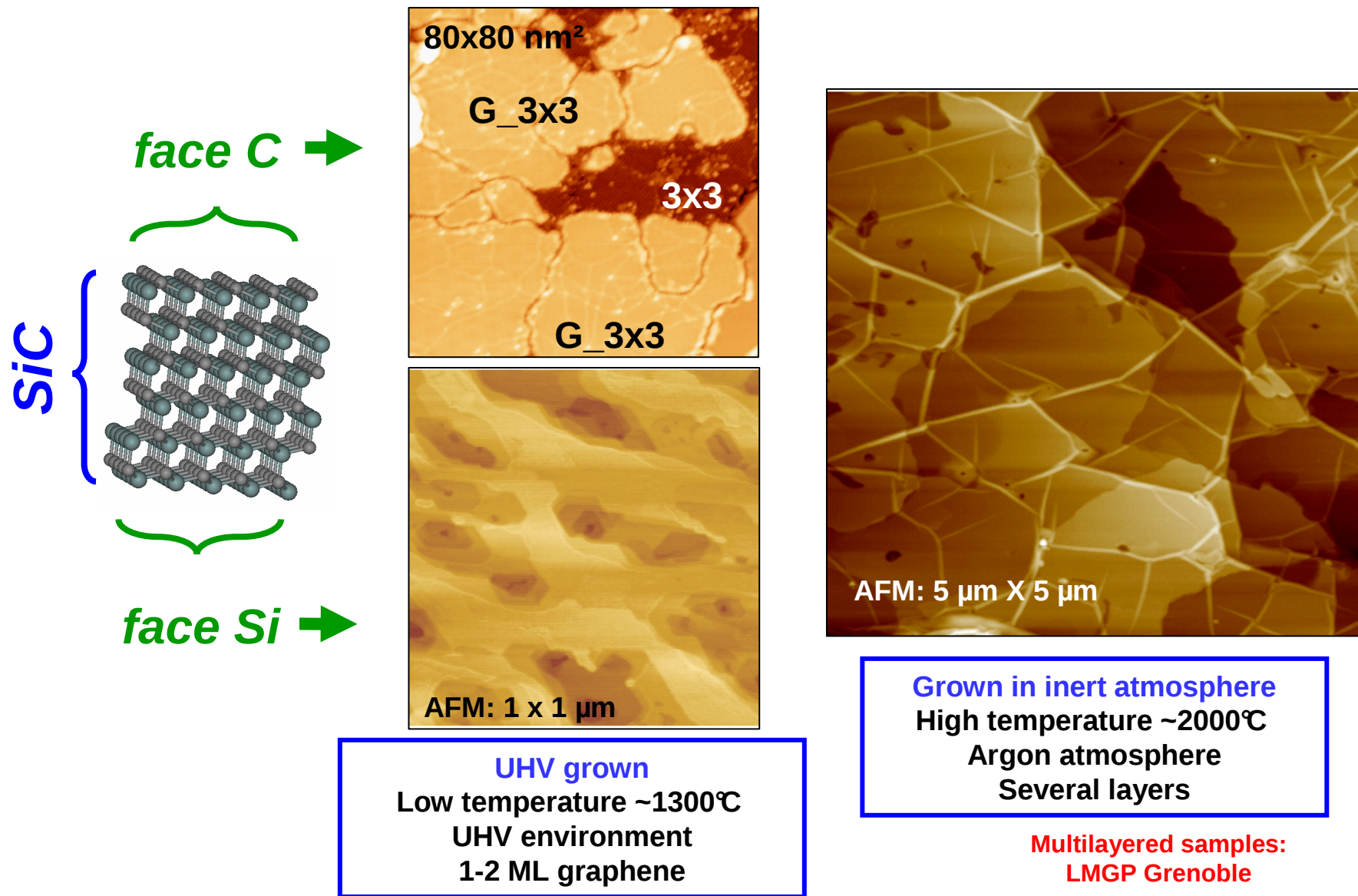
Folds and ripples



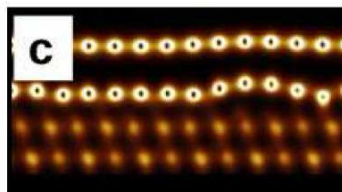
P. Ruffieux, et al, Phys. Rev. B 71, 153403 (2005)

F. Varchon,, et al, Phys. Rev. B 77, 165415 (2008)

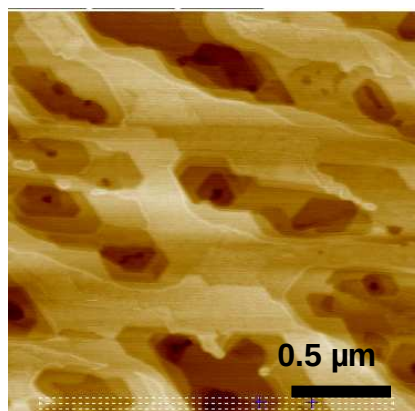
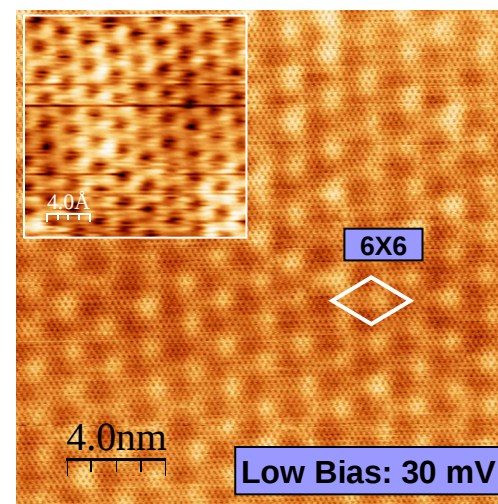
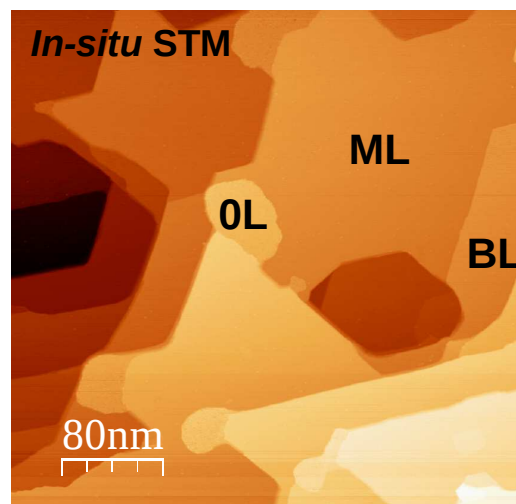
Growth of epitaxial graphene



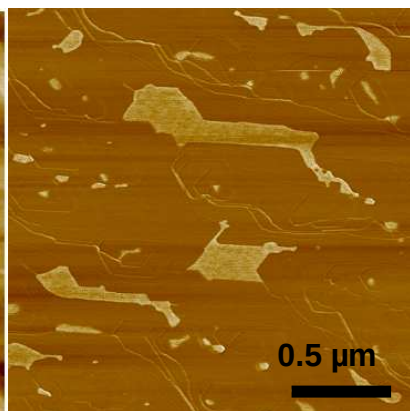
Graphene on Si face SiC



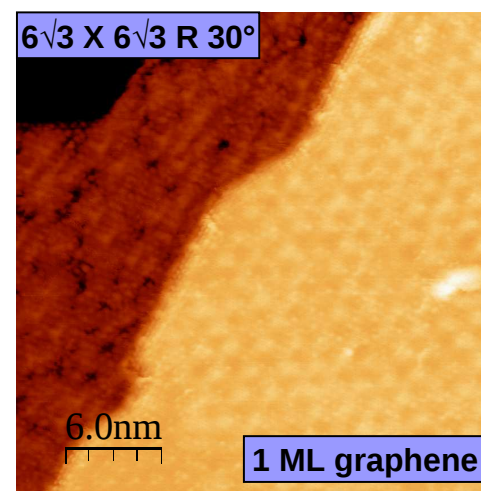
Si face:
Buffer layer coverage



Topography

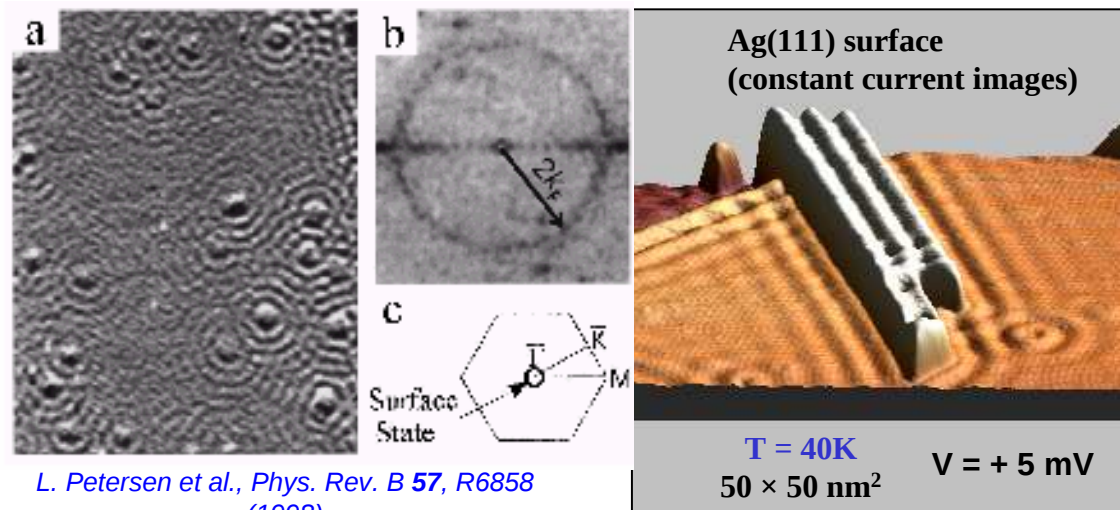


Phase



Impurities in a 2-D system

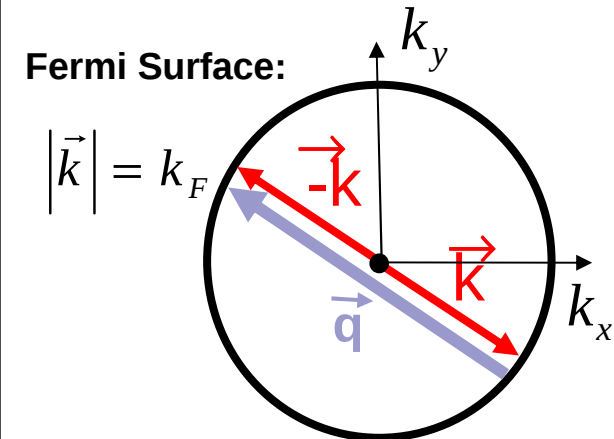
Impurities in a 2-D system



L. Petersen et al., Phys. Rev. B 57, R6858 (1998)

Collection of impurities on Cu(111)

The impurity potential induces quasiparticle interferences



LDOS modulation of
wavevector $q = 2k_F$

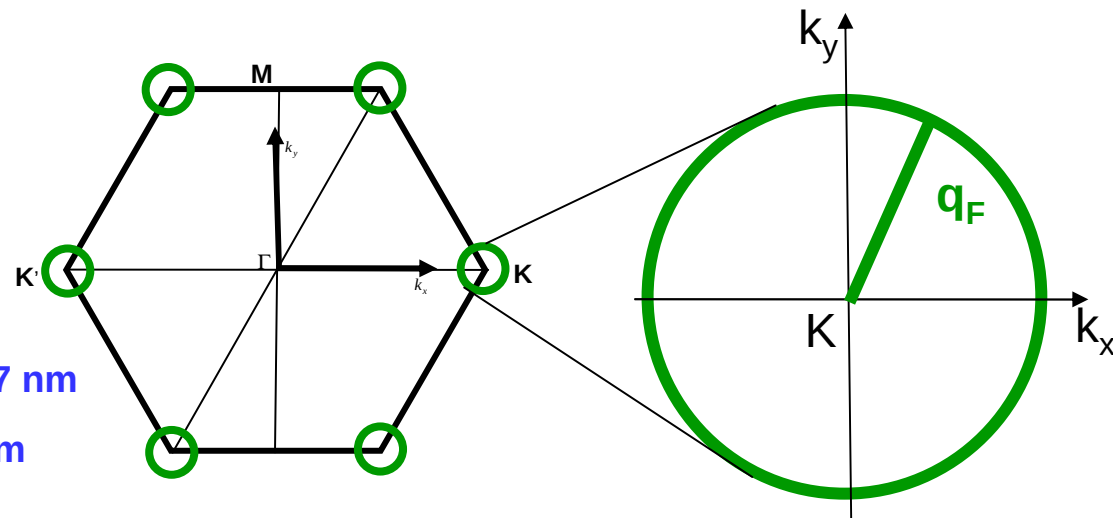
QI in ML and BL epitaxial graphene:

Fermi Surface:
ML and BL

$$\Gamma K = k_F$$

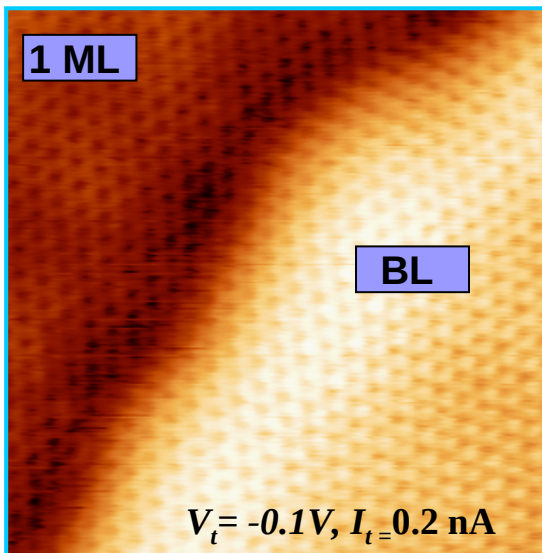
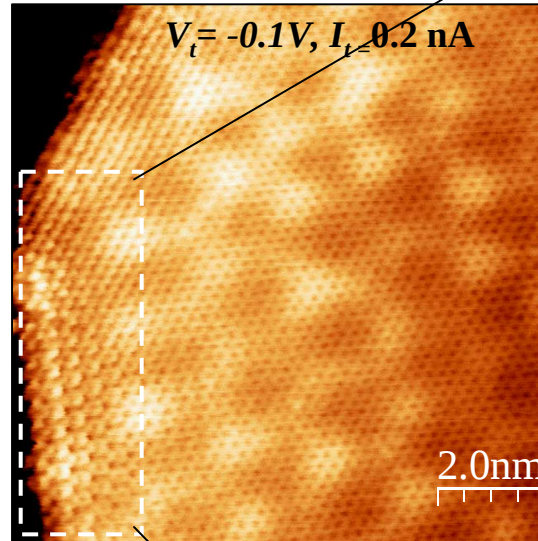
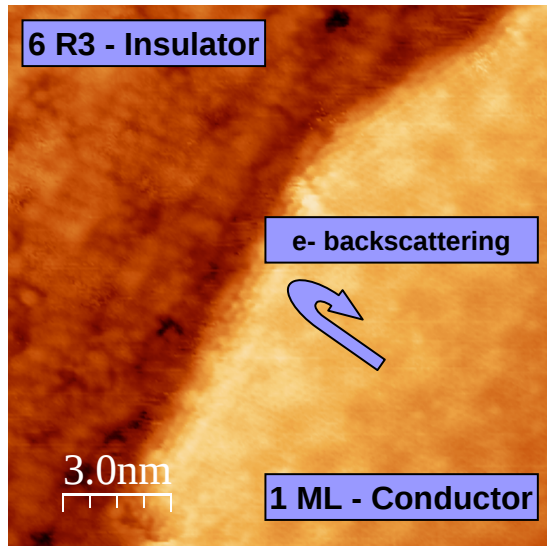
Intervalley scattering: $\lambda_F = 2\pi / k_F = 0.27 \text{ nm}$

Intravalley scattering: $\lambda_F = \pi / q_F \approx 5.2 \text{ nm}$

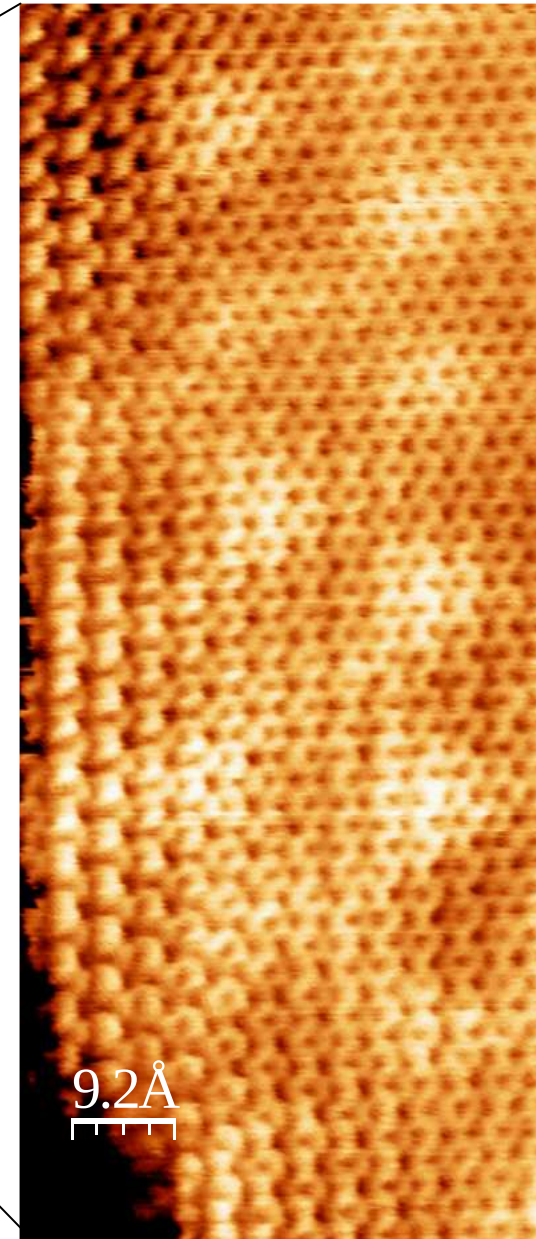


Interferences at the edges

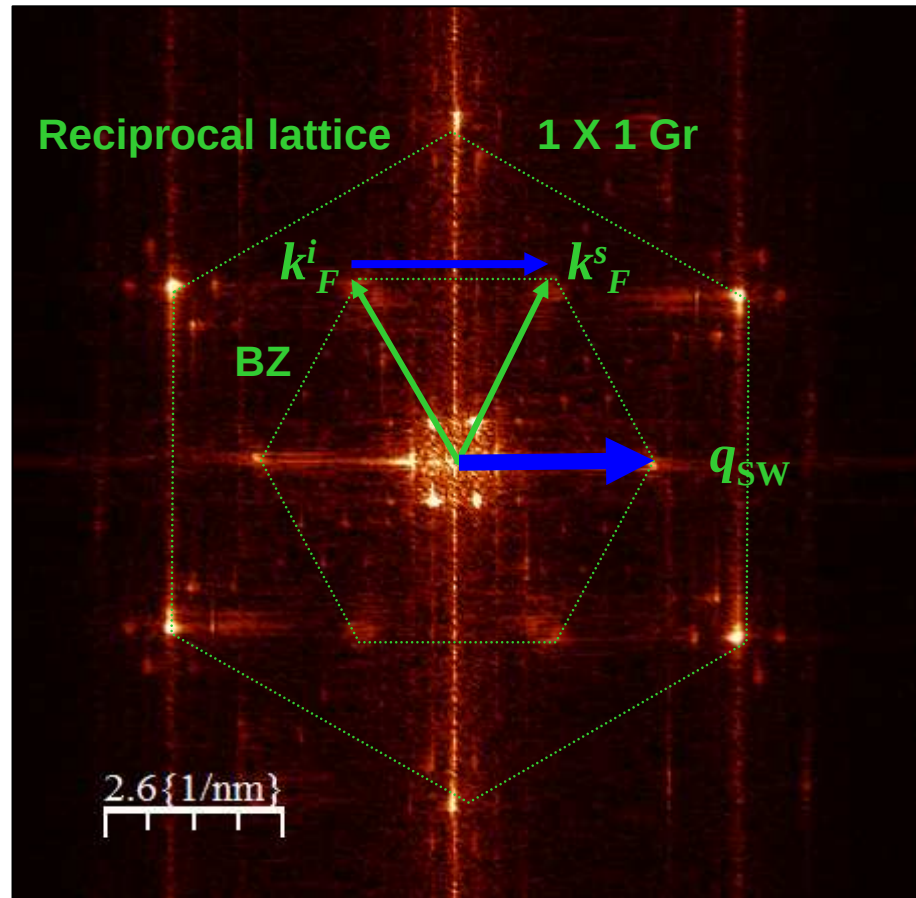
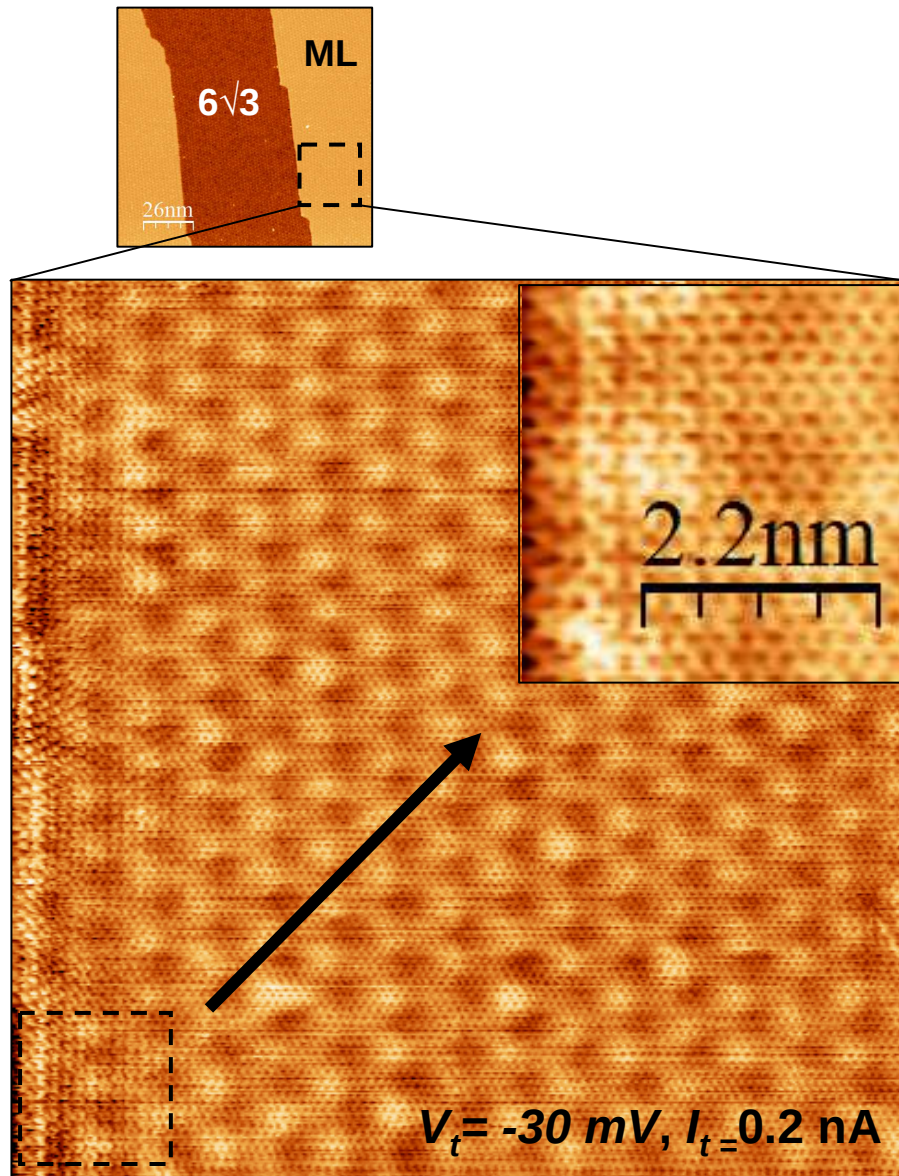
- ✓ Controlled growth
- ✓ Junction between 1 ML and buffer layer



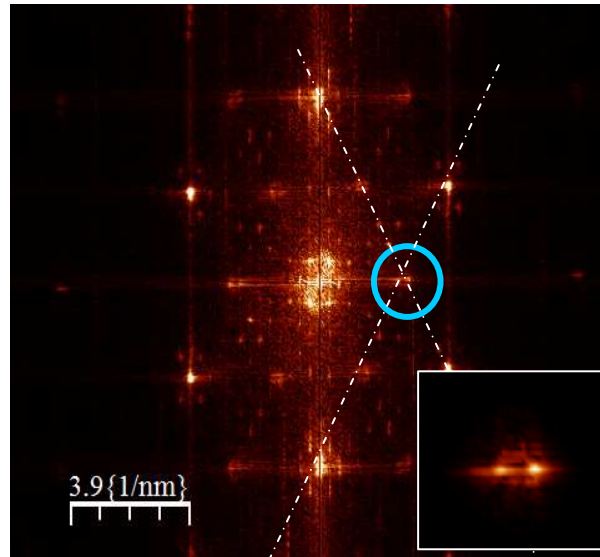
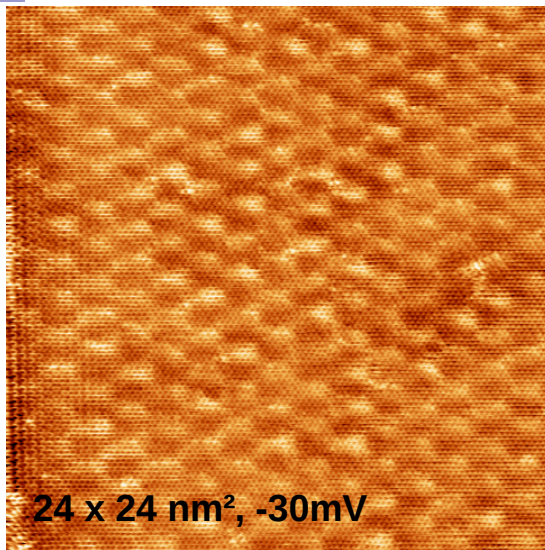
- ✓ No backscattering at ML/BL junction



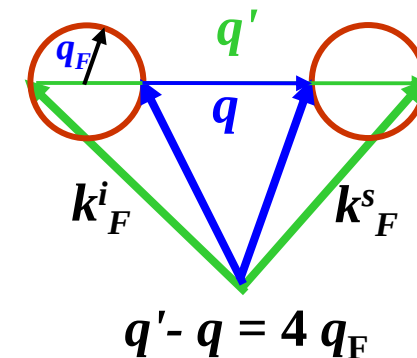
Interferences at the edges II



Interferences: Effect of doping

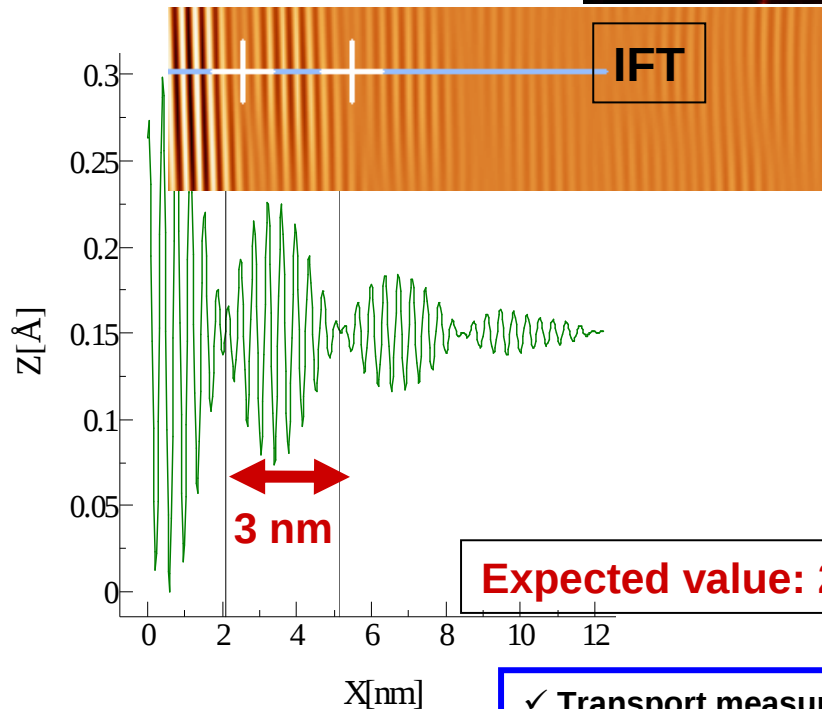


Fermi surface > finite size



Similar results:

H. Yang, et al, Nanolett. . Advanced online

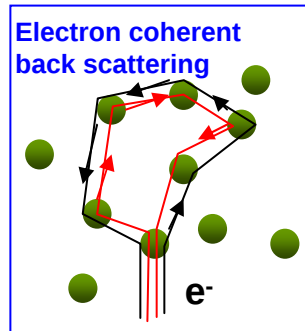


- Beating of different periods for intervalley scattering due to finite radius q_F of the Fermi surface (doping): $\Gamma K \pm 2q_F$ ($q_F = 0.06 \text{ Å}^{-1}$)
- Pseudo-period of beating events $\sim 2.9 \text{ nm}$
- Beat period 3 nm from IFT

✓ Transport measurements will complement the microscopic backscattering studies

Weak localization for a 2 DEG

A sensitive tool for QI effects



$$A_p = |A_p| \exp(iS_p)$$

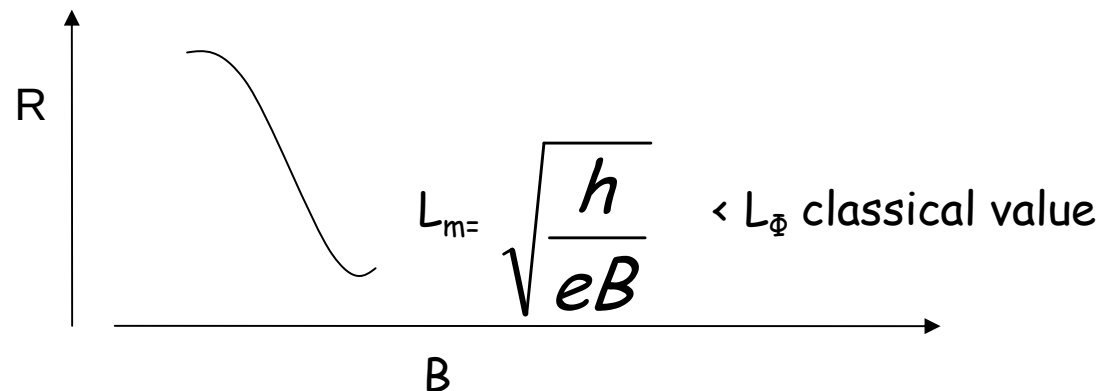
$$S_p = \int_p \vec{k} \cdot d\vec{r}$$

$$A_p A_q^* \mapsto \Delta\Phi = S_p - S_q = \int_p \vec{k} \cdot d\vec{r} - \int_q \vec{k} \cdot d\vec{r}$$

Probability of backscattering

$$P(\vec{R}, \vec{R}) = |A_p + A_{-p}|^2 = |A_p|^2 + |A_{-p}|^2 + A_p A_{-p}^* + A_p^* A_{-p}$$

Conventional systems:
inelastic / magnetic impurities

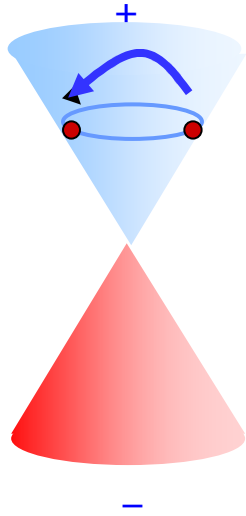


Localization for graphene

Graphene:

Inelastic / Elastic

Berry's phase $\rightarrow$ antiphase

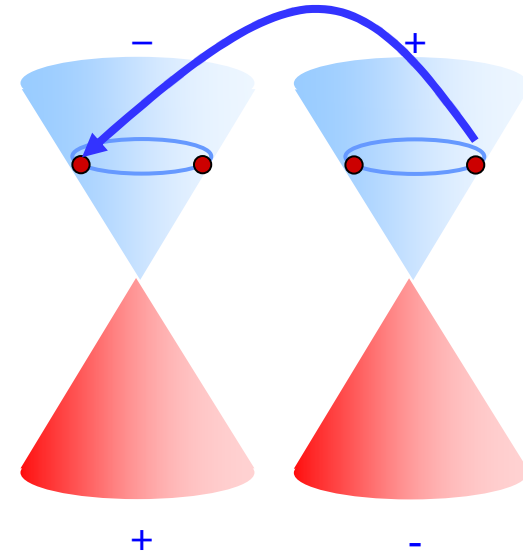
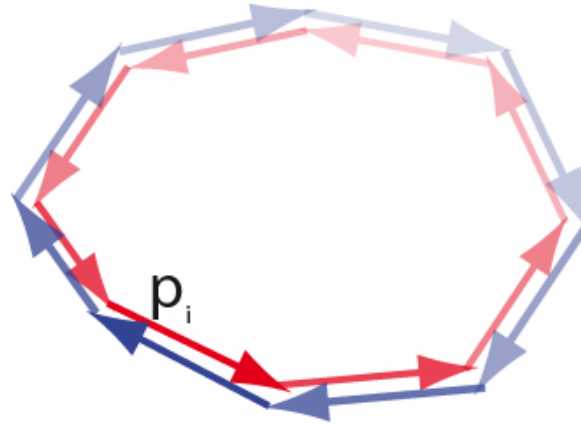


For an intra-valley scattering :

The isospin stays linked to the momentum direction.

2π rotation changes the sign of wavefn

ANTI-LOCALIZATION



For an inter-valley scattering :

The isospin is averaging to zero

LOCALIZATION

Low field MR: theoretical developments

$$\Delta\sigma(B) = \frac{e^2}{\pi h} \left(F\left(\frac{\tau_B^{-1}}{\tau_\phi^{-1}}\right) - F\left(\frac{\tau_B^{-1}}{\tau_\phi^{-1} + 2\tau_i^{-1}}\right) - 2F\left(\frac{\tau_B^{-1}}{\tau_\phi^{-1} + \tau_i^{-1} + \tau_*^{-1}}\right) \right)$$

Intervalley

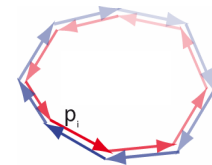
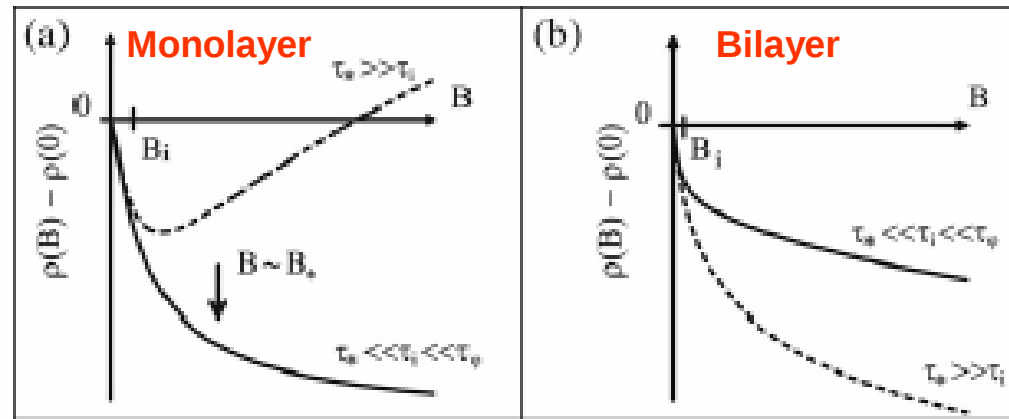
Intravalley

$$F(z) = \ln z + \psi\left(\frac{1}{2} + \frac{1}{z}\right), B_{\varphi,i,*} = \frac{\hbar c}{4De} \tau_{\varphi,i,*}^{-1}$$

E. McCann, et al., *Phys. Rev. Lett.* **97**, 146805 (2006).

V. I. Falko, K. et al., *SolidState Comm* **143**, 33 (2007).

K. Kechedzhi, et al., *Eur. Phys. J. Spec. Topics*, **148**, 39 (2008).



Scattering mechanisms

Inelastic: Phase breaking, τ_φ^1

Elastic: Chirality breaking, $\tau_s^1 \rightarrow$ Sharp defects, dislocations

Intravalley, $\tau_i^1 \rightarrow$ Lattice spacing sized

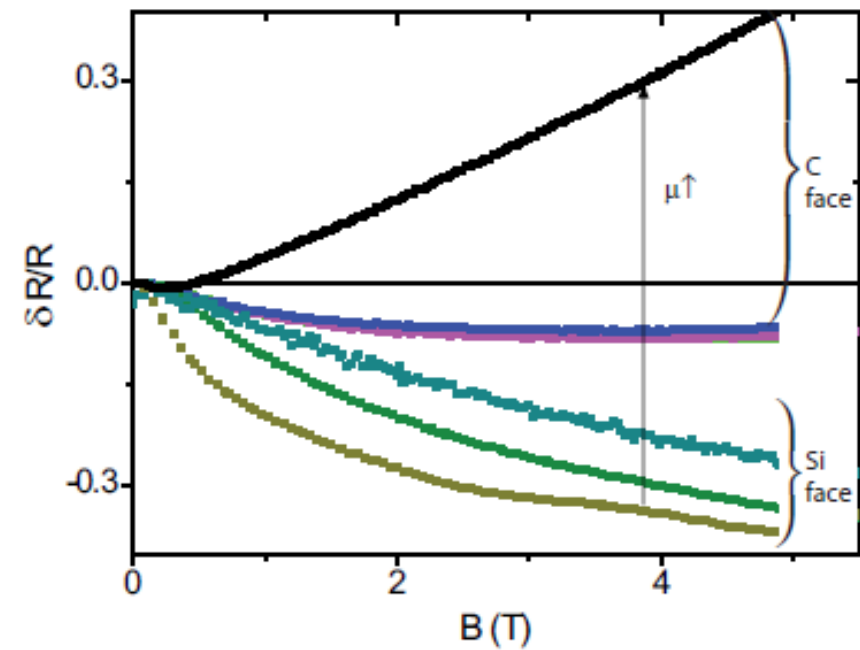
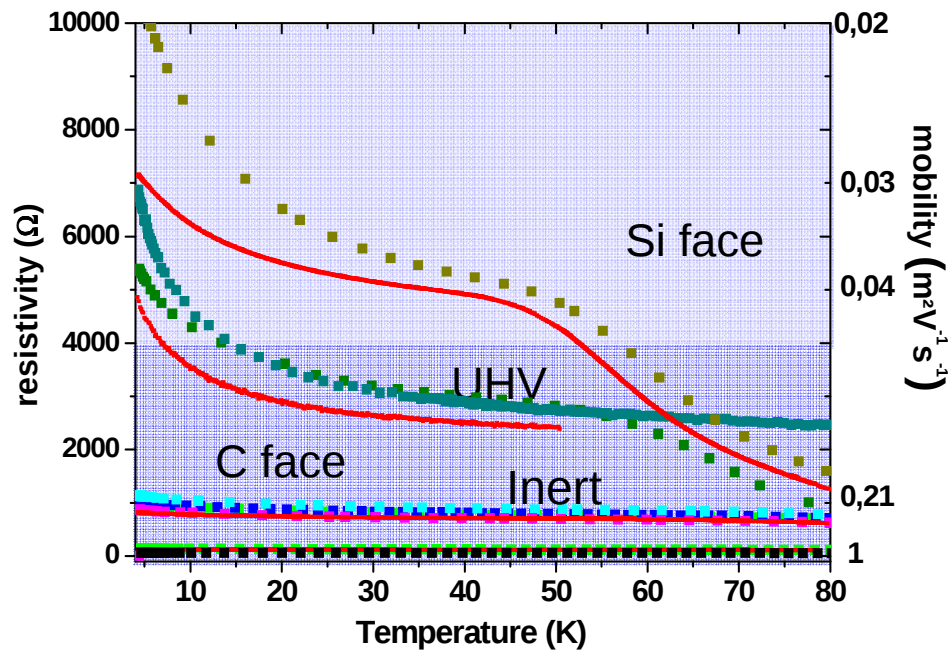
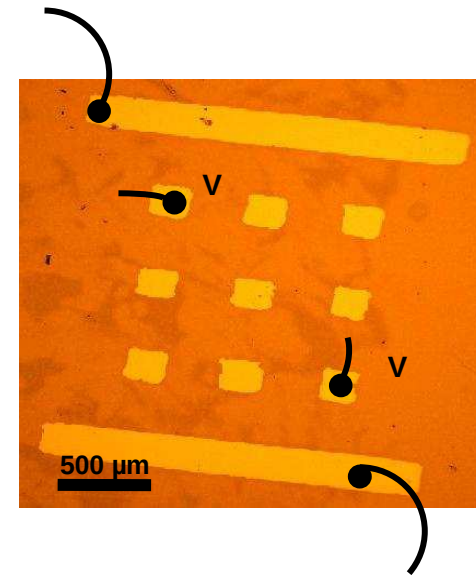
Interplay restores or supresses WL

Can we observe different regimes versus the growth conditions ?

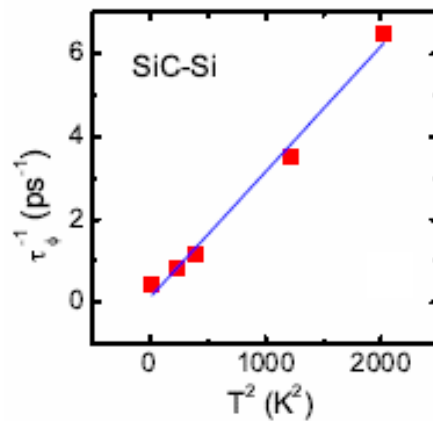
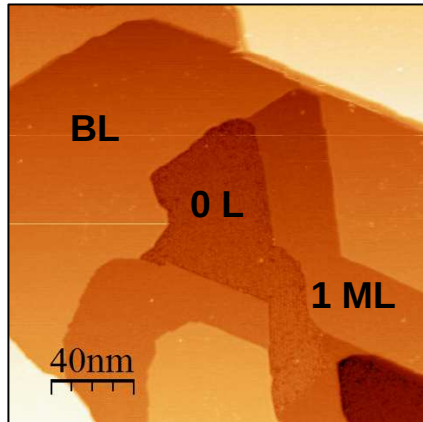
2D Transport properties

Sample conditions:

- ✓ Contact on large area 2 mm X 2 mm
- ✓ Metal pads by shadow mask
- ✓ Resist free deposition

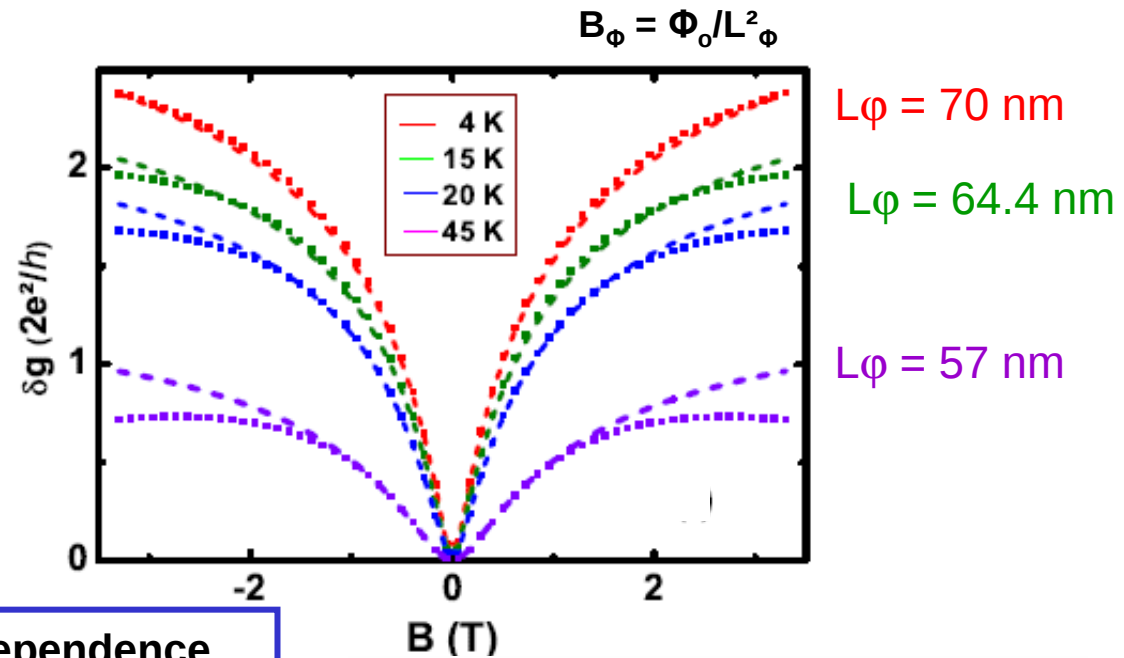


Localization on Si face



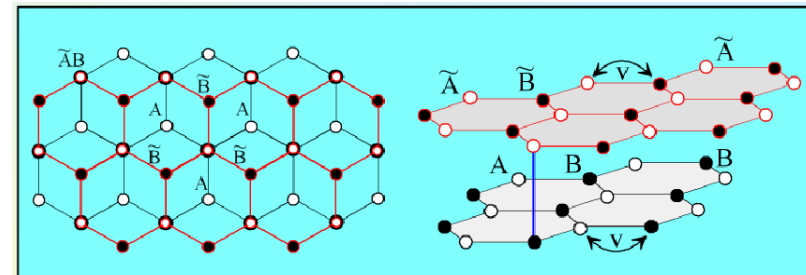
T^2 dependence
e-ph scattering ?

$$\begin{aligned}\tau_i^{-1} &= 1.02 \cdot 10^{13} \text{ s}^{-1} \\ \tau_w^{-1} &= 1.63 \cdot 10^{13} \text{ s}^{-1} \\ \tau_*^{-1} &= 2.65 \cdot 10^{13} \text{ s}^{-1}\end{aligned}$$

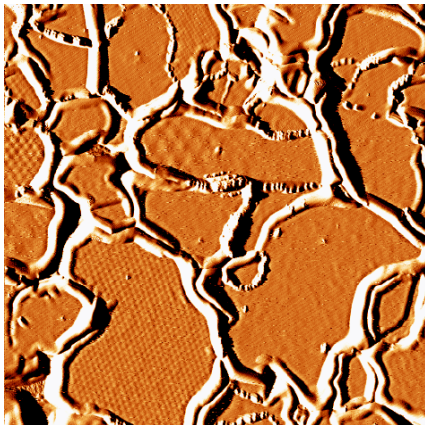


$$\Delta\sigma(B) = \frac{e^2}{\pi h} \left(F\left(\frac{\tau_B^{-1}}{\tau_\phi^{-1}}\right) - F\left(\frac{\tau_B^{-1}}{\tau_\phi^{-1} + 2\tau_i^{-1}}\right) \right)$$

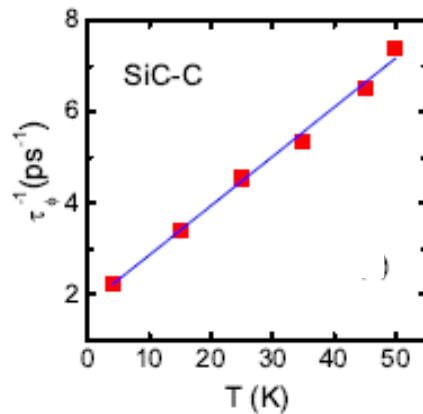
Opposite sign $\rightarrow +2F\left(\frac{\tau_B^{-1}}{\tau_\phi^{-1} + \tau_i^{-1} + \tau_*^{-1}}\right)$



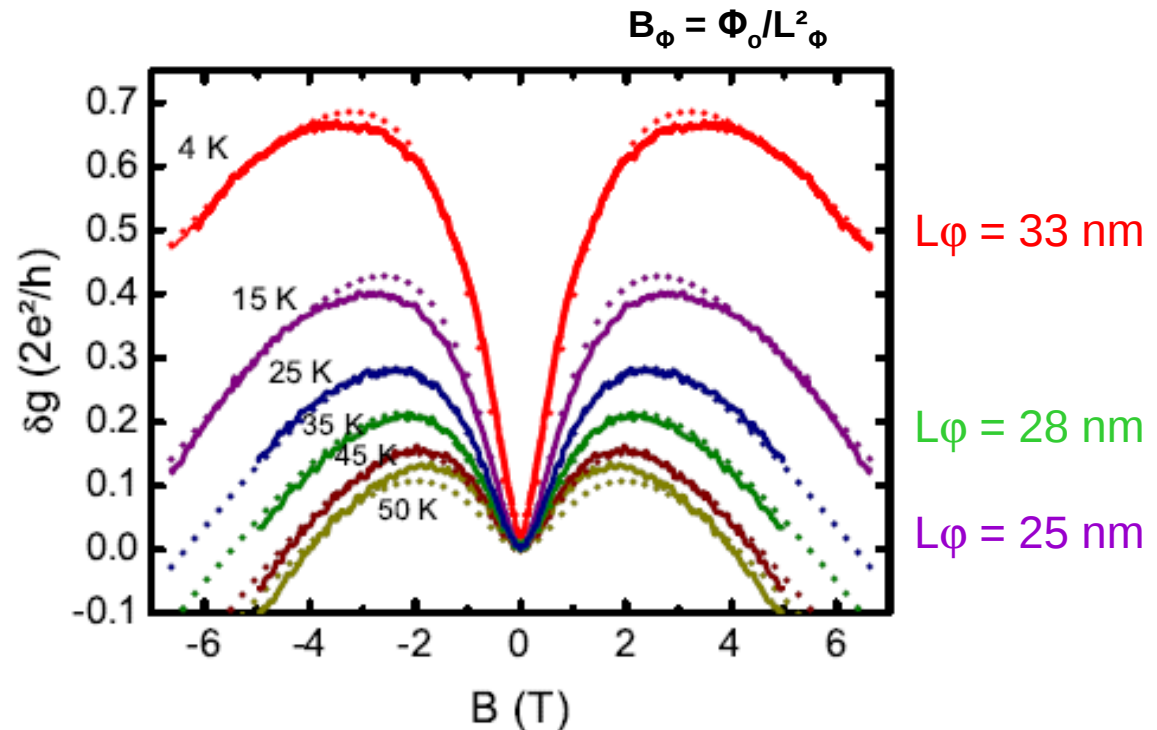
Anti-localization on the C face



150 x 150 nm²



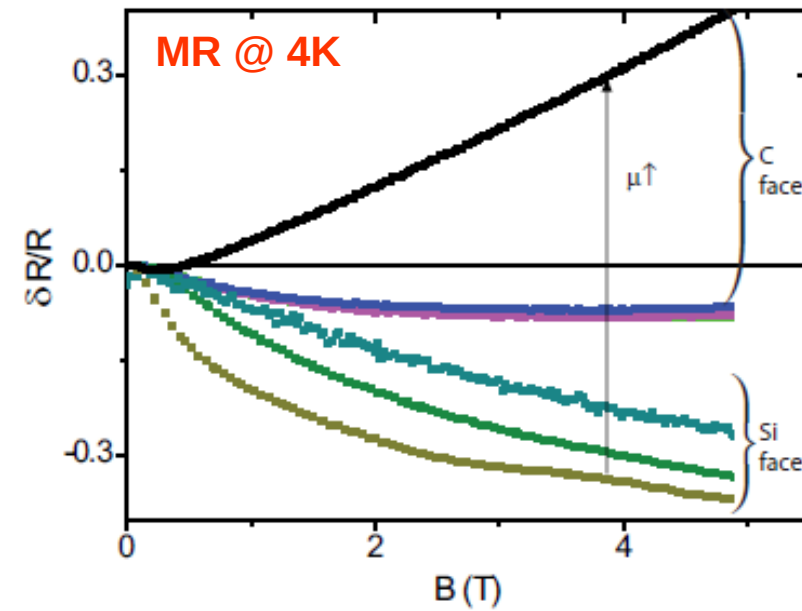
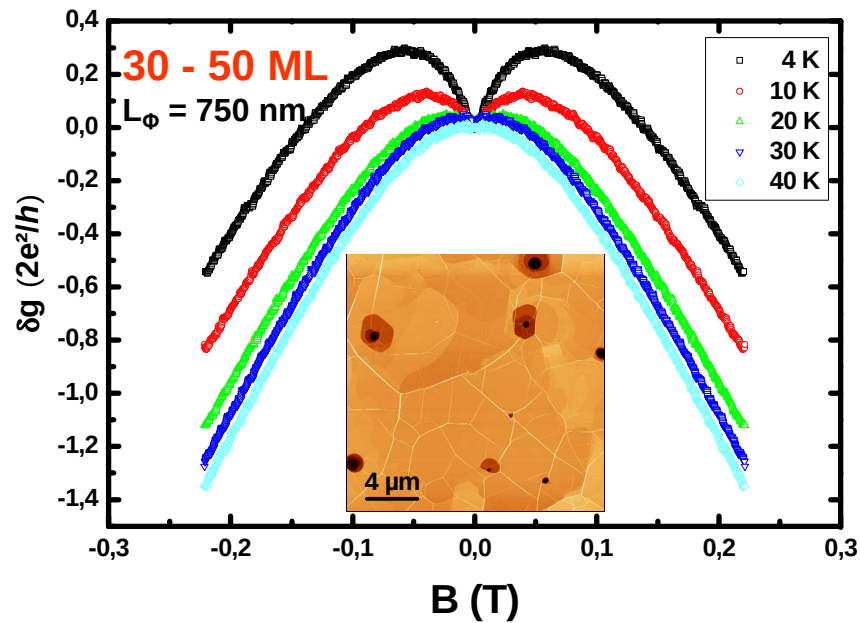
$$\begin{aligned}\tau_i^{-1} &= 6.6 \cdot 10^{12} \text{ s}^{-1} \\ \tau_w^{-1} &= 7.4 \cdot 10^{12} \text{ s}^{-1} \\ \tau^{*-1} &= 6.6 \cdot 10^{12} + 7.4 \cdot 10^{12} = 1.4 \cdot 10^{13} \text{ s}^{-1} \\ \tau_{\phi} / \tau_i \text{ and } \tau_{\phi} / \tau^* &\text{ relatively small}\end{aligned}$$



$$\begin{aligned}\Delta \sigma(B) &= \frac{e^2}{\pi h} \left(F\left(\frac{\tau_B^{-1}}{\tau_{\phi}^{-1}}\right) - F\left(\frac{\tau_B^{-1}}{\tau_{\phi}^{-1} + 2\tau_i^{-1}}\right) \right. \\ &\quad \left. - 2F\left(\frac{\tau_B^{-1}}{\tau_{\phi}^{-1} + \tau_i^{-1} + \tau_*^{-1}}\right) \right).\end{aligned}$$

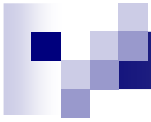
Linear dependence
Altshular-Aronov prediction for e-e

Multilayers: deviation from true WAL



- ✓ Large localization amplitude $> e^2/h$
- ✓ Weak interlayer coupling
- ✓ Large $l_e \sim 300 \text{ nm}$
- ✓ D dependent on $B \rightarrow$ linear positive MR
- ✓ Other contributions to WAL slope (Coulomb scattering, tunneling)?





Conclusions

- Morphology (STM, AFM)- QI at step edges
- 2D transport properties.
- Form WAL to conventional WL
- Importance of stacking